-1-

ONS00181 09/802,726

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Hadizad et al.

Serial No.:

09/802,726

Filing Date:

March 12, 2001

Group Art Unit:

2813

Examiner:

Schillinger, Laura M

Title:

SEMICONDUCTOR COMPONENT AND METHOD

OF MAKING

I HEREBY CERTIFY THAT THIS CORRESPONDENCE IS BEING FACSIMILE TRANSMITTED TO THE PATENT AND TRADEMARK OFFICE, ATTN EXAMINER Laura M. Schillinger, AT THE FAX NO. (703) 872-9318

Date of Facsimile Transmission James Stipanuk Name of Person Signing Certificate

Honorable Commissioner of Patents, Washington, D.C. 20231

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2003 MAR 4

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AMENDMENT

SIR:

In response to the office action mailed 12/04/2002, please amend the above-identified application as follows.

03/11/2003 JDADE1 00000002 501086 09802726

01 FC:1202 02 FC:1201

144.00 CH 84.00 CH

F-171

P.001

T-451

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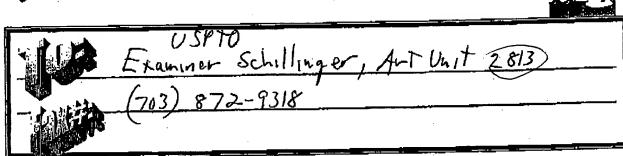
ON Semiconductor

5005 East McDowell Road Phoenix, AZ 85008



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Intellectual Property Department Facsimile 602-244-3169



Application Number-09/802,726 FAX RECEIVED Docket Number-04500181 MAR 4 2003 14 pages of Amendment 1 cover page

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